

10/574985

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Sumifusa IKENOUCHI : **Mail Stop: PCT**  
Serial No. NEW : Attorney Docket No. 2006\_0500A  
Filed April 7, 2006 :

PLASMA PROCESSING APPARATUS,  
CONTROL METHOD FOR PLASMA  
PROCESSING APPARATUS, AND  
EVALUATION METHOD FOR PLASMA  
PROCESSING APPARATUS  
[Corresponding to PCT/JP2004/016179  
Filed October 25, 2004]

THE COMMISSIONER IS AUTHORIZED  
TO CHARGE ANY DEFICIENCY IN THE  
FEES FOR THIS PAPER TO DEPOSIT  
ACCOUNT NO. 23-0975

**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examination of the instant application, please enter and consider the following amendments and remarks as follows:

ATTACHMENT C